

00862.022397

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Z. E. Cabrera
Keiji YOSHIMURA)	
	:	Group Art Unit: 2125
Application No.: 09/964,648)	
	:	Confirmation No.: 1952
Filed: September 28, 2001)	
	:	
For: EXPOSURE APPARATUS, SEMICONDUCTOR)	October 27, 2006
DEVICE MANUFACTURING METHOD,	:	
EXPOSURE APPARATUS MAINTENANCE)	
METHOD AND SEMICONDUCTOR	:	
MANUFACTURING FACTORY)	

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: